

Propitious Micro-/Nano-electromechanical system as a key to ultraminiaturization of the microwave atomic clock

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Background

Big data & Digital twin



Space-time synchronization



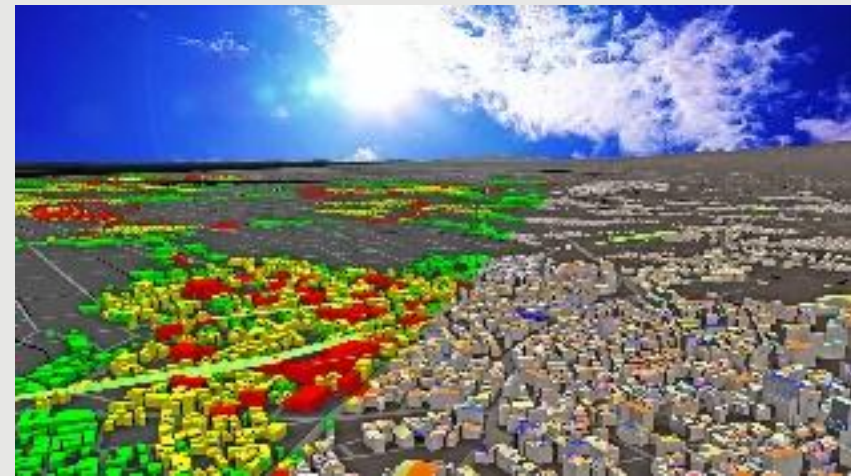
Dynamic digital twin



City scape on digital-twin with high definition



Simulation of urban fire spread



Simulation of solar power generation efficiency

Ref.: PLATEAU supported by MLIT

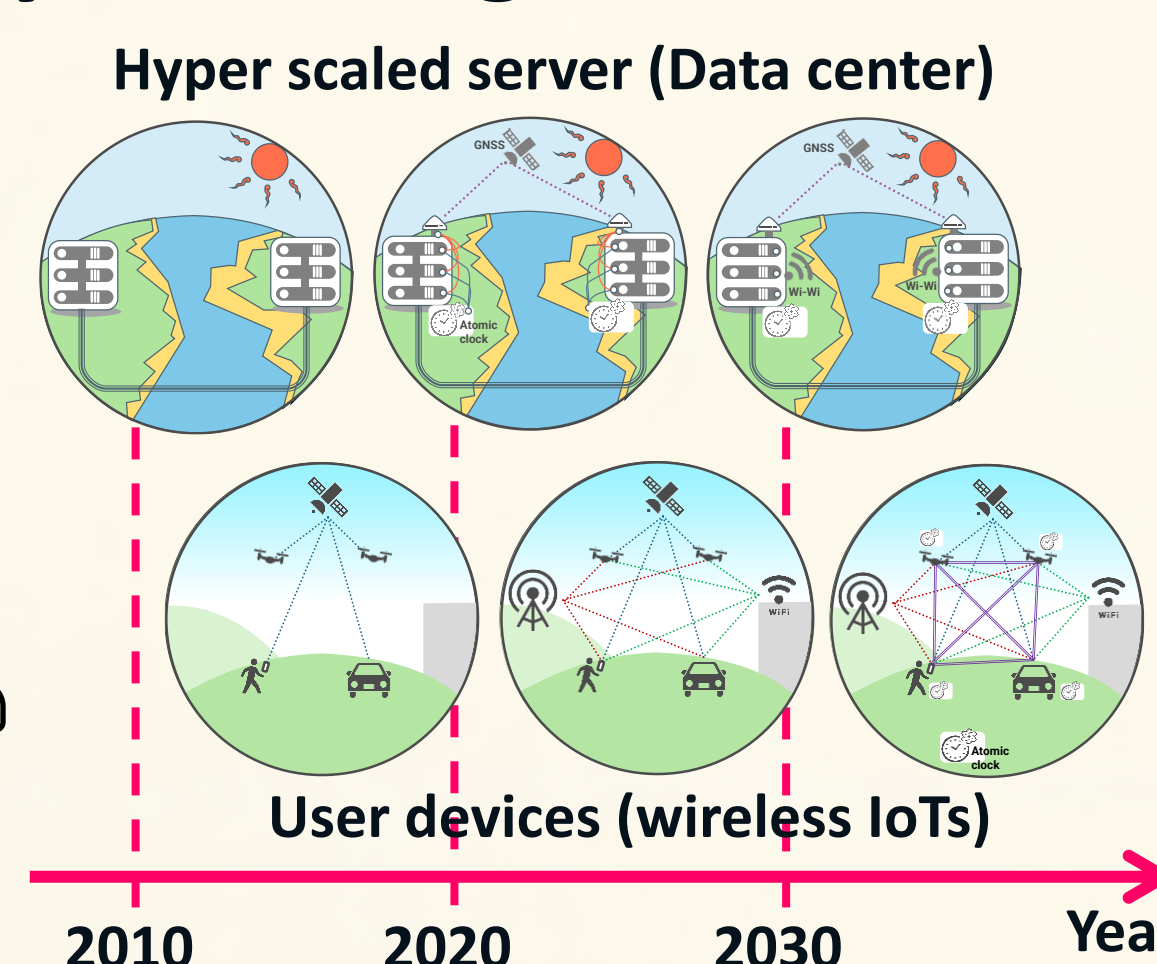
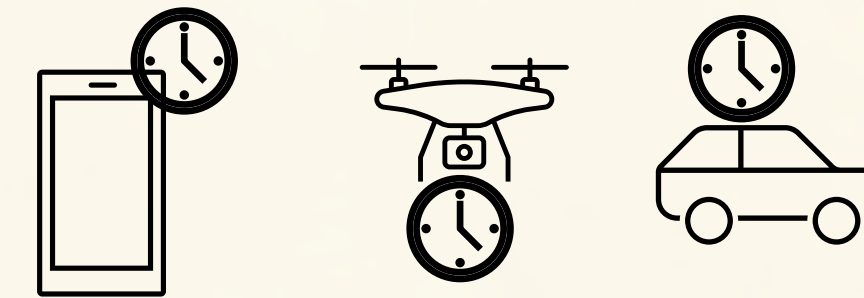
What's "Dynamic".

Adding space-time information to the data that constitutes the digital twin

- Near real-time feedback (smart city)
 - Smart traffic control
 - Power/Heat/Flood control
- High-precision simulations through data assimilation due to time series alignment
- Anti-poisoning and truly diverse data ingestion in AI processing

How do we make dynamic digital twin?

Implementing a **stable clock module** each user device



<Our activity>

Miniaturized atomic clock

Synchronizer of time and space

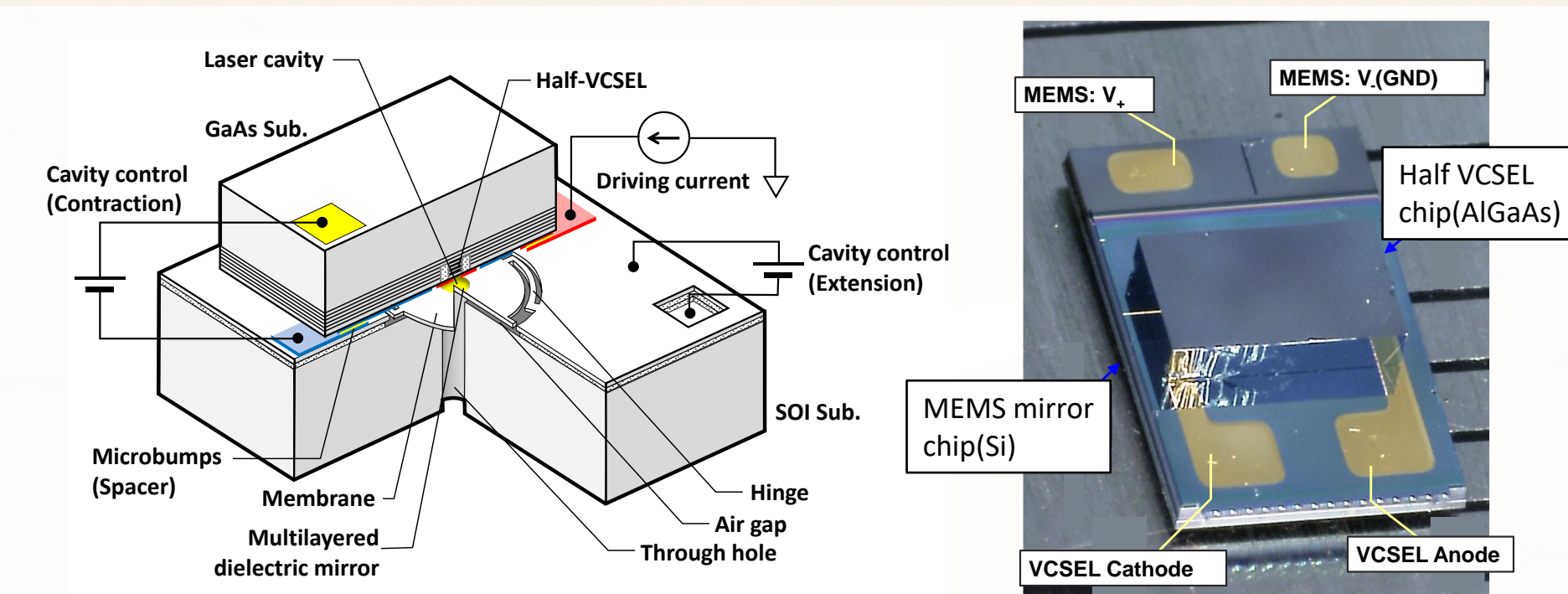
Time stamper
Time estimation algorithms

Development Progress of Key Components for Ultraminiaturized Atomic Clock

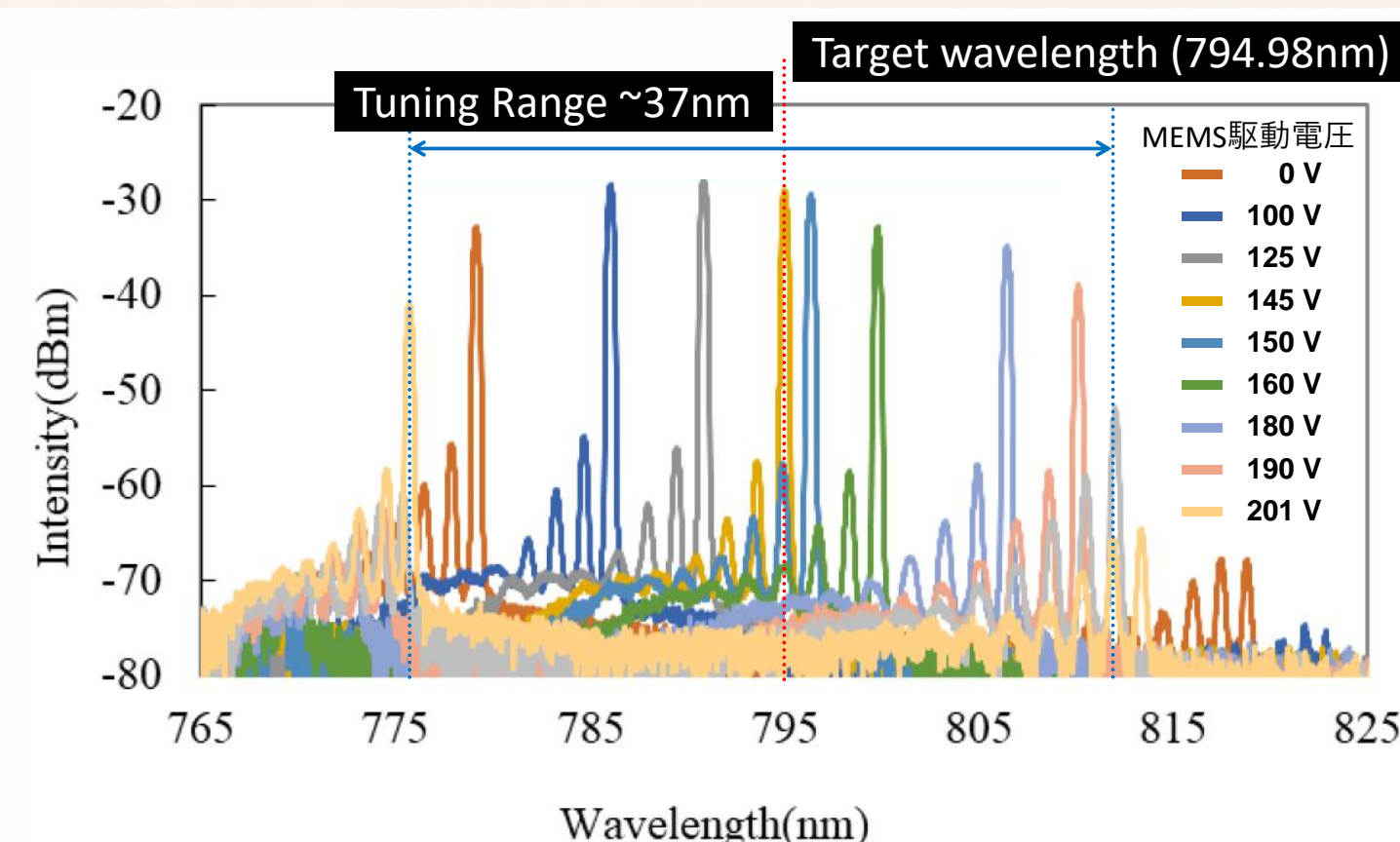
VCSEL

Development of wavelength tuning technology injection current or temperature control for screening cost reduction

<Device Structure>

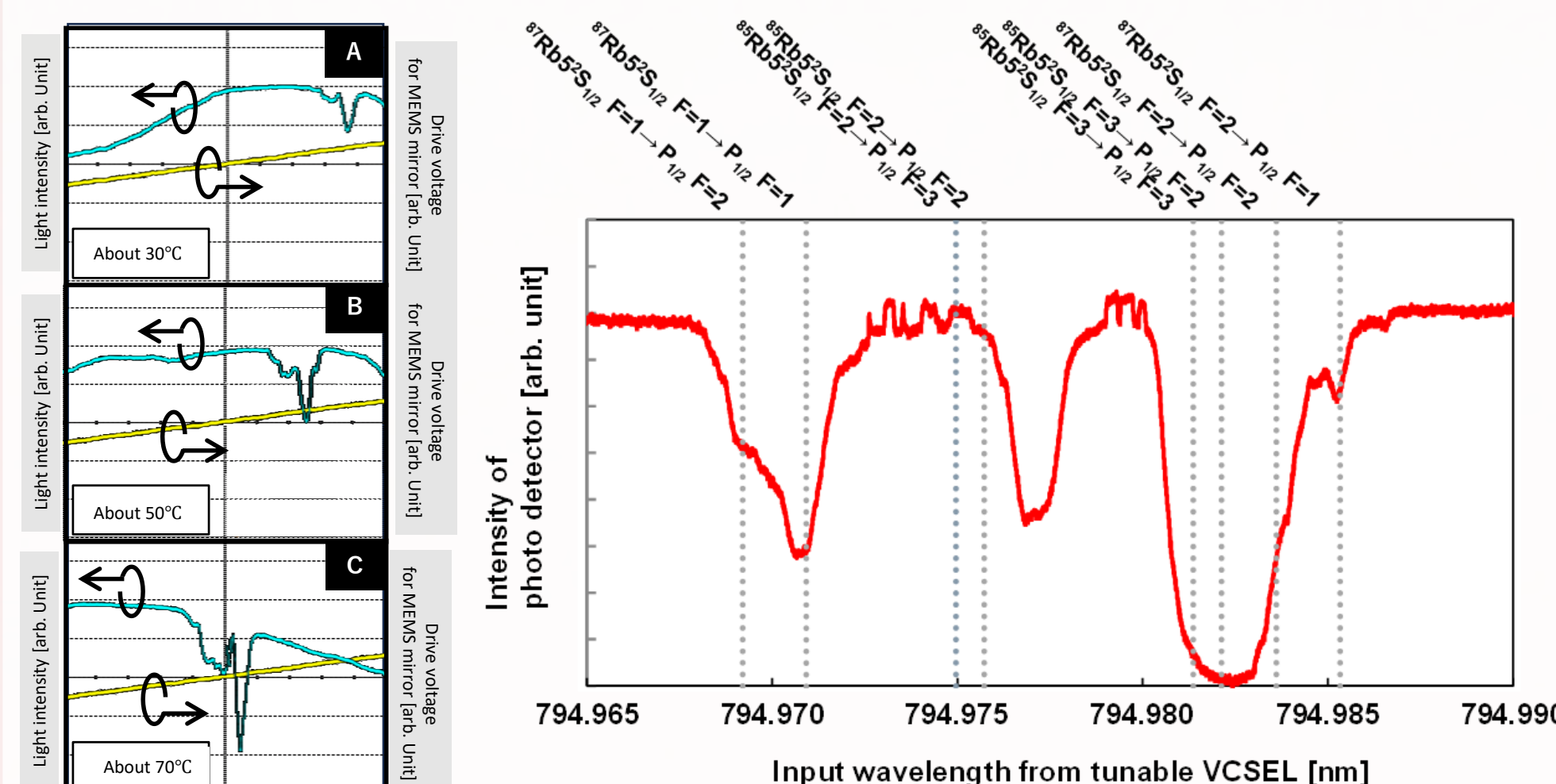
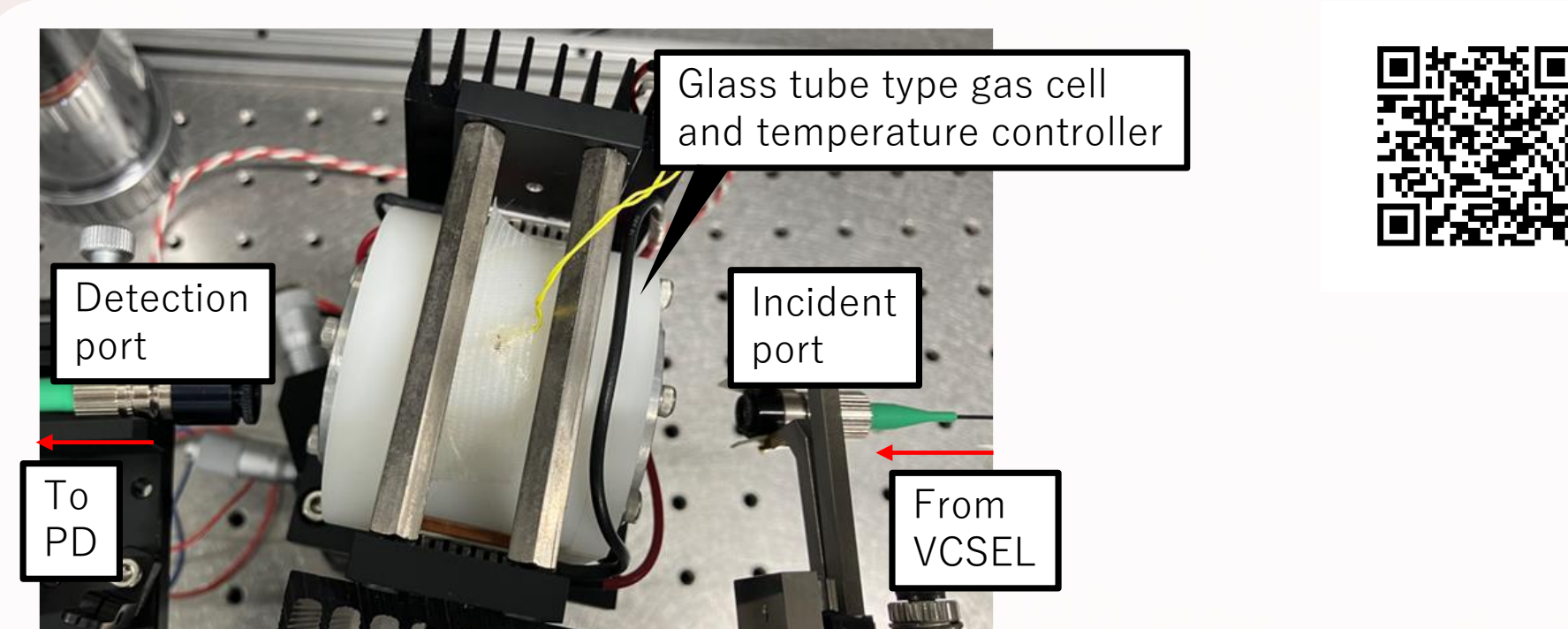


<Wavelength Tuning Range>



Using a mechanically controlled wavelength tuner, we successfully capture Rb absorption lines.

<Observation of Absorption Spectra>



We observed the absorption lines of Rb using a MEMS-based laser sweep.

Gas cell

<Fabrication Technology>

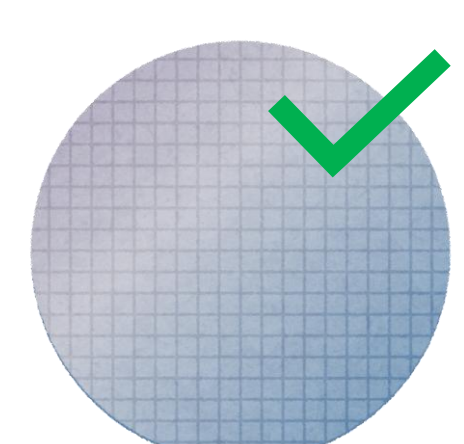
RbN₃ is a clean solid source of Rb that produces only nitrogen, a useful buffer gas, during decomposition.

It is powdery crustal.

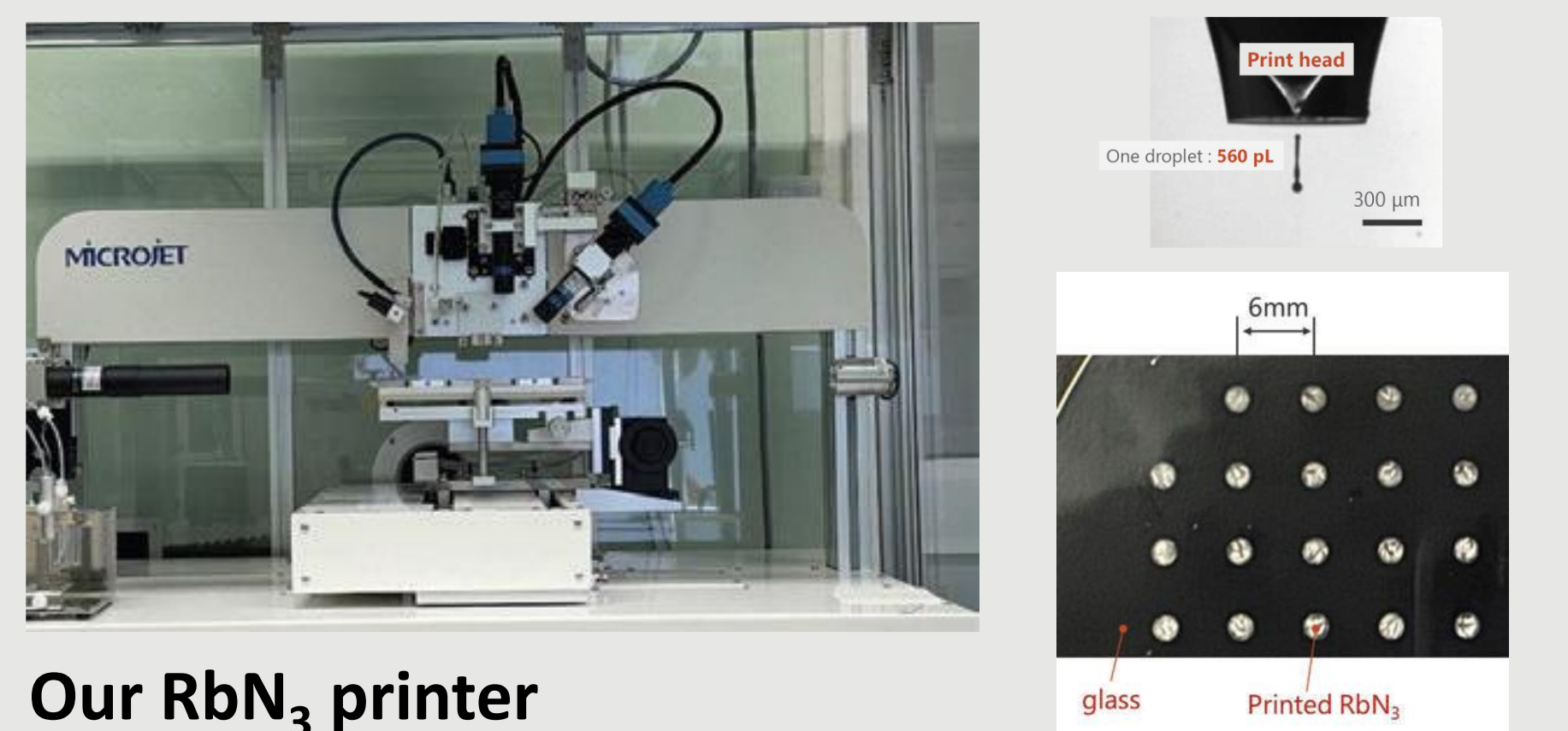
- Clean room handling **X**
- Control PI/pg order **X**



Wafer delivery of RbN₃
Clean room handling **O**
→ RbN₃ is fixed on the wf
Control PI/pg order **O**



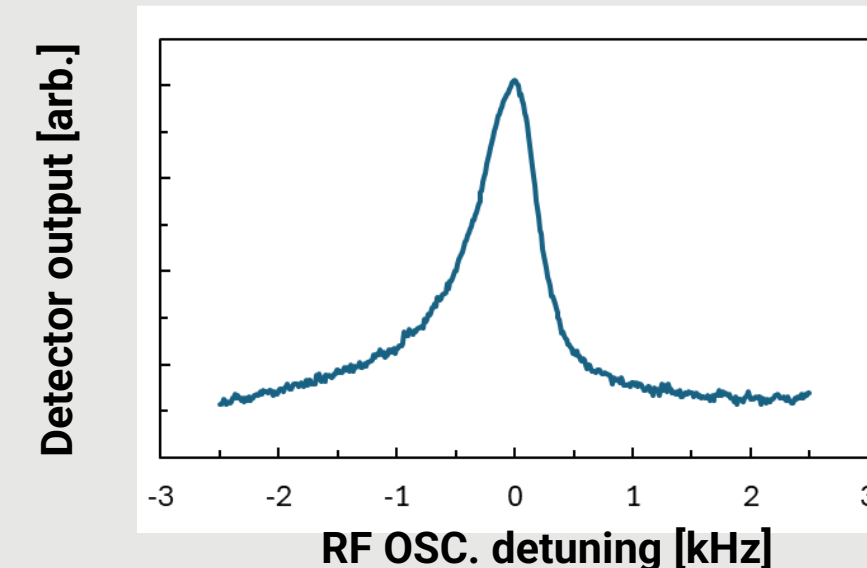
Inkjet printing is the best solution for wafer delivery.



Our RbN₃ printer



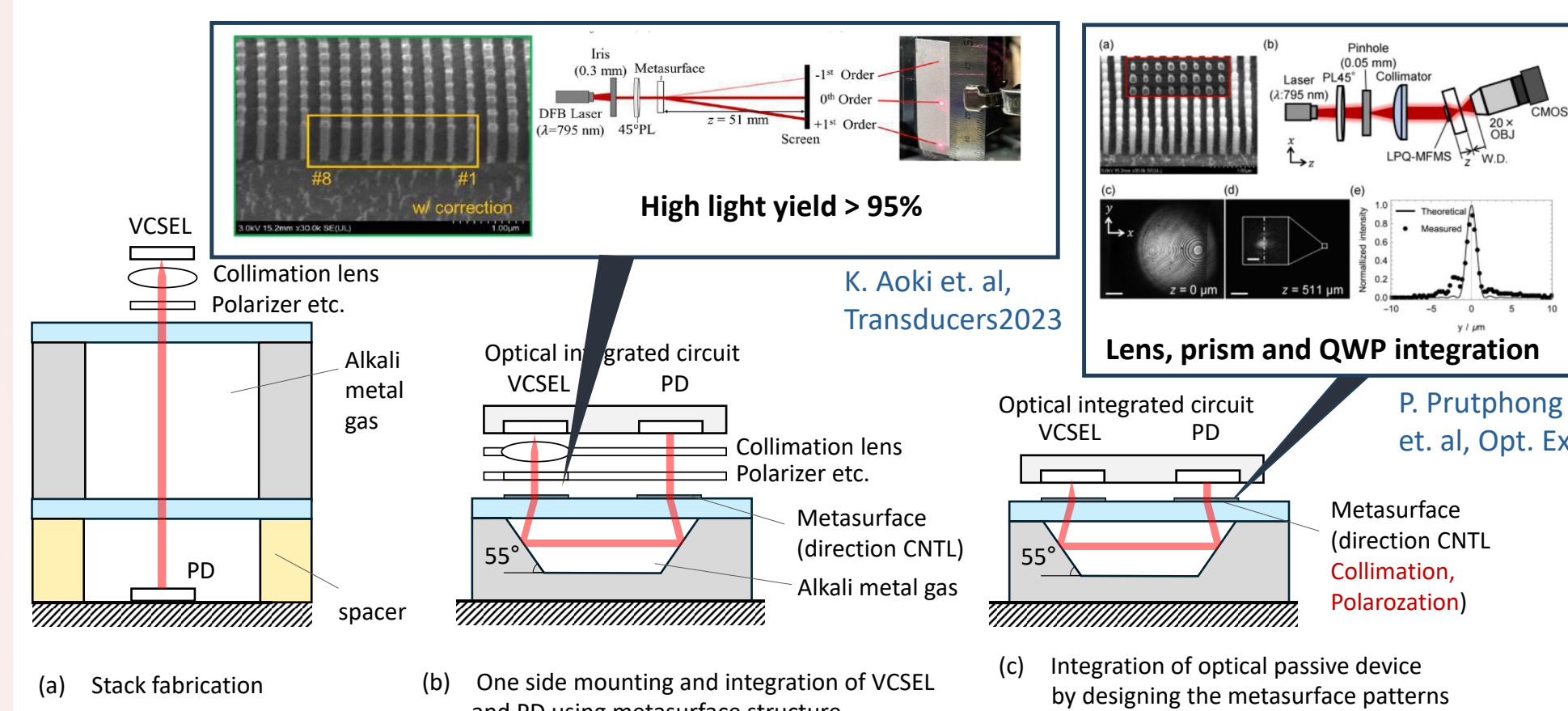
Printed RbN₃ Gas cell



We successfully detect the CPT resonance

<Low Height Gas Cell>

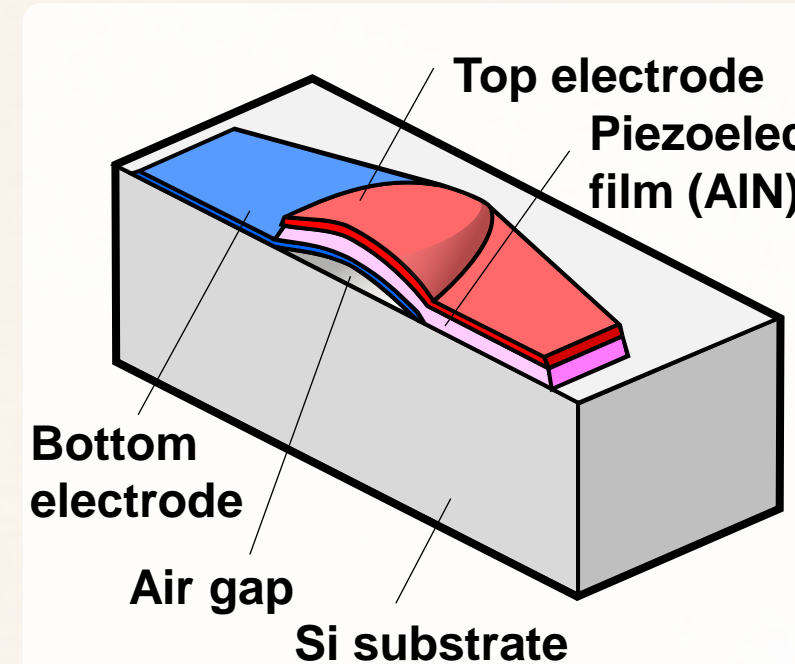
Low loss optical folding is essential to compress the height and increase the integration density



Micro oscillator

Development of ultraminiaturized RF oscillator for the CPT MW atomic clock

<Ultra compact MEMS resonator>

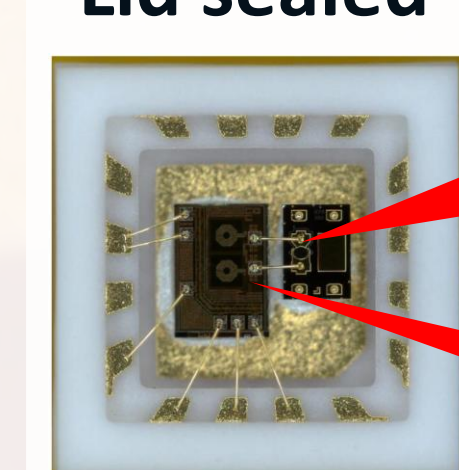


Thin film bulk acoustic resonator (FBAR):
FBAR is a bulk acoustic resonator using piezoelectric film on the wafer
○ small size
○ low insertion loss
○ CMOS compatibility

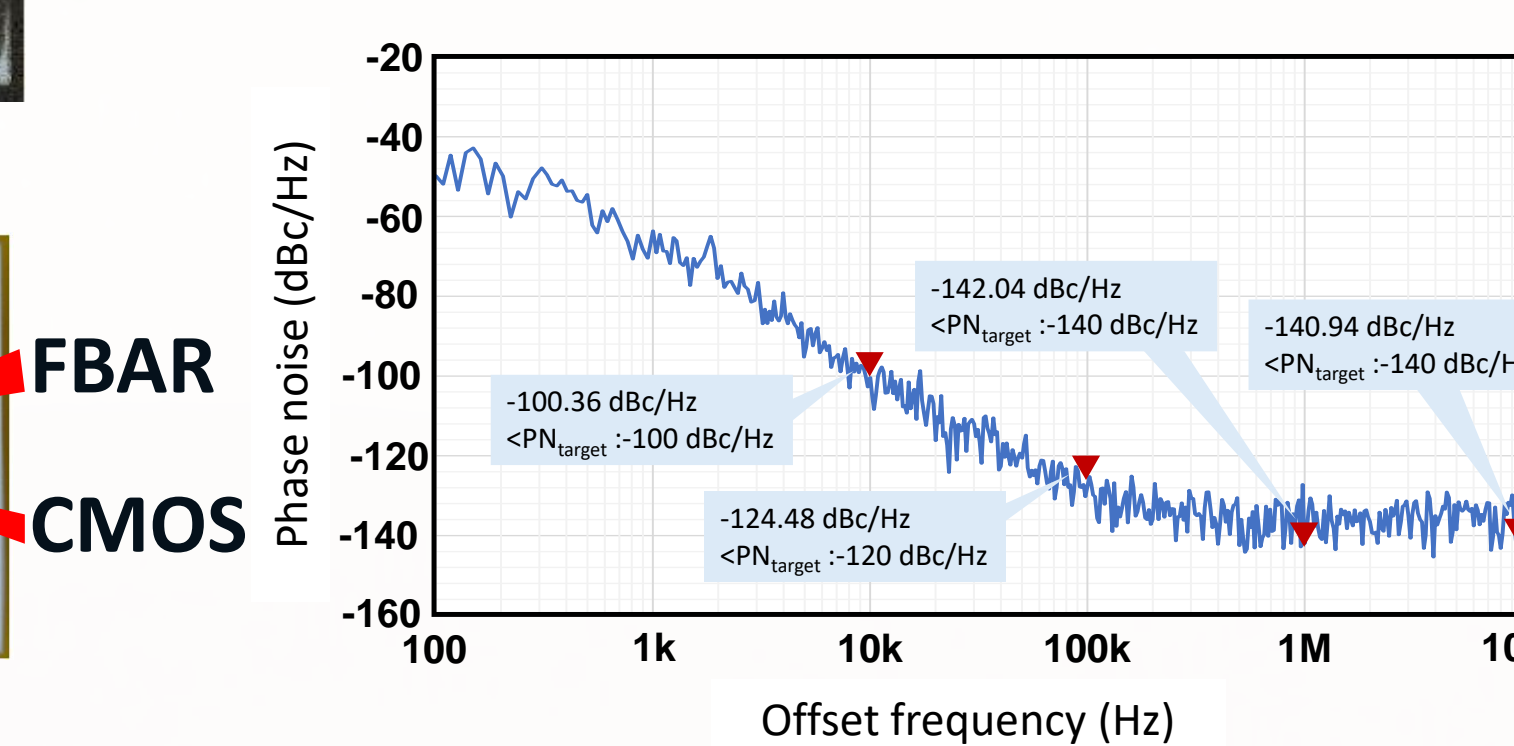
<LTCC Package>

We developed 3 mm x 3 mm LTCC cavity packaged 3.4 GHz band FBAR OSC with very low phase noise.

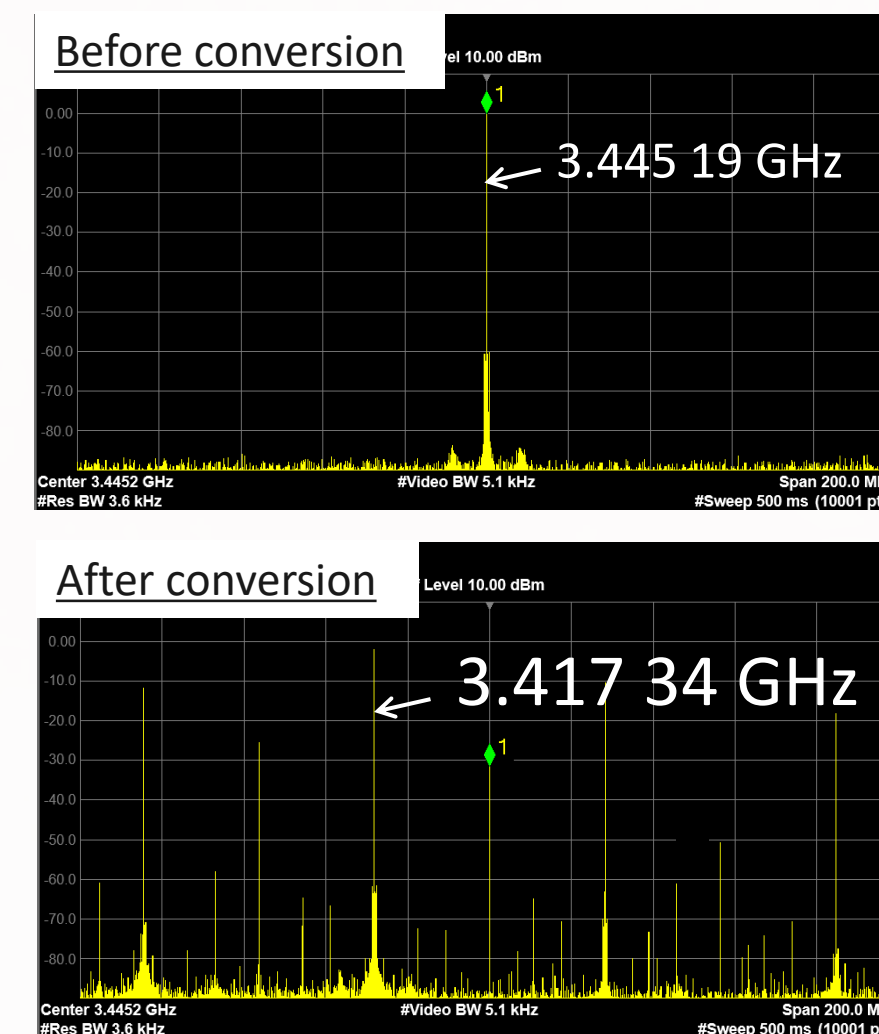
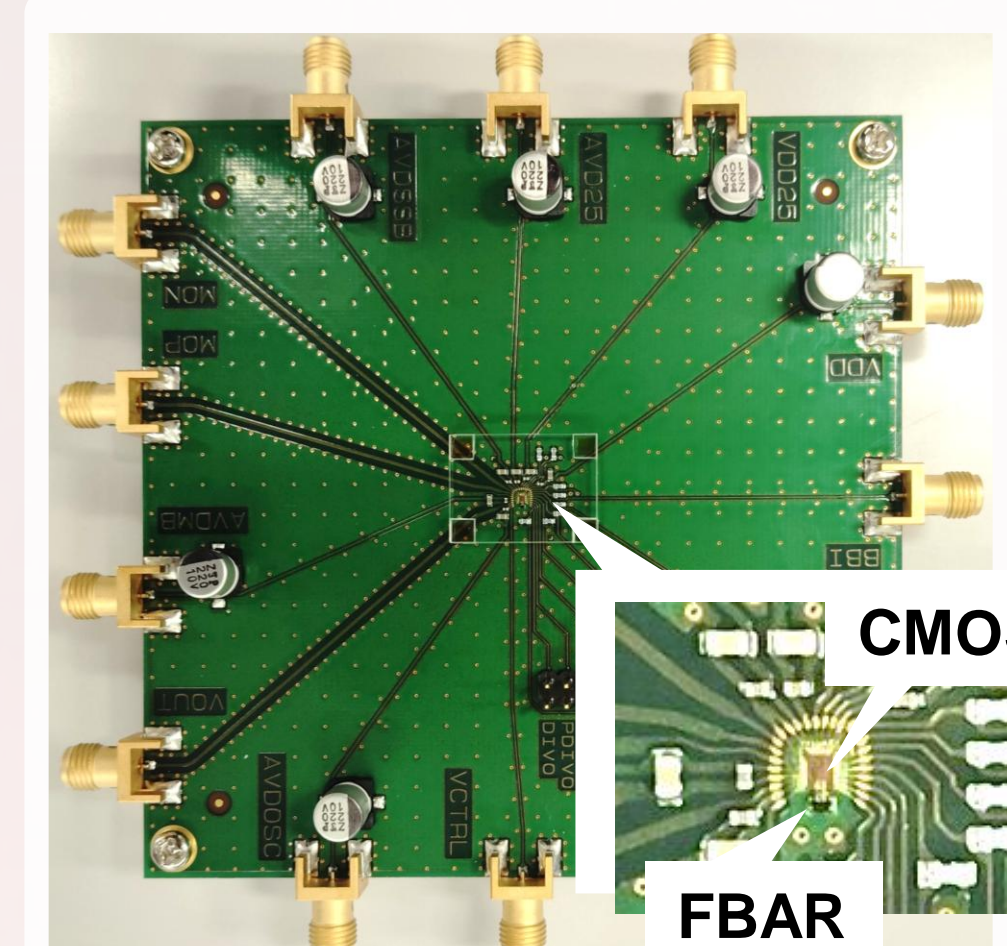
Lid sealed



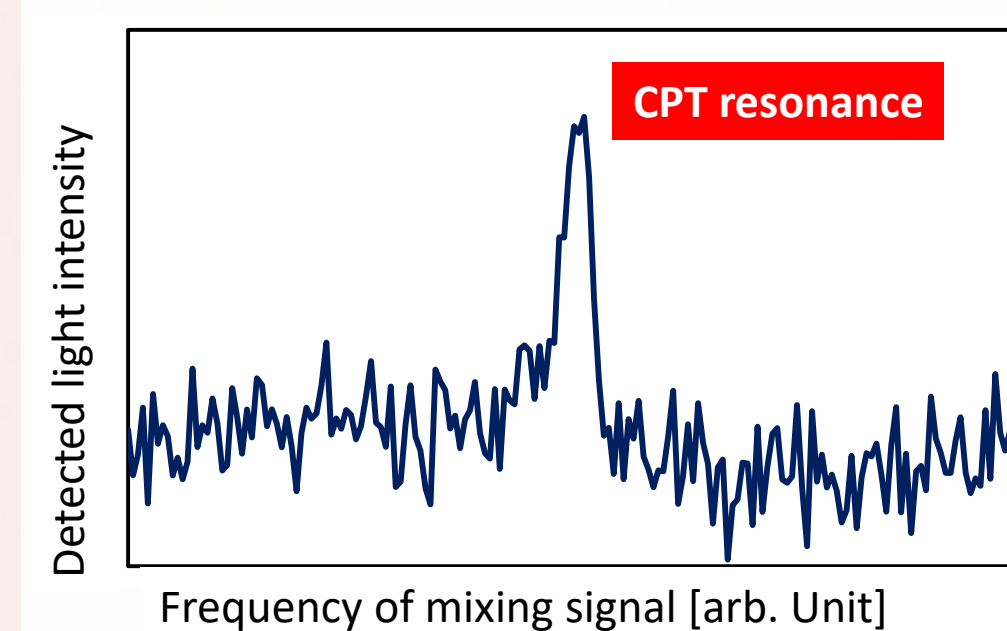
Lid open



<Wide frequency tuning with single side band modulation (SSBM)>



<Implementation to the atomic clock>



We successfully detect the CPT resonance

<Conclusion> At NICT, to meet various newly proposed technical requirements for 6G, we are developing various technologies that enable time-space synchronization at the device level. In this presentation, we introduced the developments aimed at miniaturizing atomic clocks. In the MEMS wavelength tuner, we adopted a unique MEMS movable mirror stabilization technology and succeeded in obtaining the absorption line of Rb. In the gas cell development, we proposed new manufacturing technology and optical control technology suitable for mass production. In addition, we made good use of MEMS resonators in the control circuit of the atomic clock, proposed RF control technology that is highly compatible with digital technology, and succeeded in obtaining the CPT resonance of Rb.

<Acknowledgement> Part of this work was supported by SCOPE (No. 195003003) and research and development for expansion of radio wave resources (JPJ000254) from the Ministry of Internal Affairs and Communications (MIC), Japan, and the Japan Society for the Promotion (JPAS) of KAKENHI under Grant 23K17858 and Grant 22K04894

